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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. ONO, et al
Serial No.: 09/249,292 (CPA)
Filed: February 12, 1999
For: METHOD AND APPARATUS FOR TREATING SURFACE OF SEMICONDUCTOR
Group: 1746
Examiner: A. Olsen

PRELIMINARY AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

October 31, 2001

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified CPA filed on this date and is responsive to the Office Action dated July 31, 2001.

IN THE CLAIMS:

Please add the following new claim:

--28. A method according to claim 1, wherein the on-off modulating of the rf bias voltage is effected at a cycle longer than a cycle of the rf bias voltage waveform.--

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